L Number	Hits	Search Text	DB	Time stamp
1	23		USPAT	2003/09/29 11:12
1 -	8	sputter\$3 with ((silicon adj nitride) or	USPAT	2003/09/26 13:37
[	_	(silion adj (oxide or dioxide)) or		
		(aluminum adj (oxide or dioxide))) with		
		platinum with cobalt	}	l j
-	8	(sputter\$3 with ((silicon adj nitride) or	USPAT	2003/09/26 13:36
		(silion adj (oxide or dioxide)) or		
		(aluminum adj (oxide or dioxide))) with		}
		platinum) and magnetic\$3		
-	12		USPAT	2003/09/26 14:04
		(oxide or dioxide)) or (aluminum adj		1
İ		(oxide or dioxide))) with platinum with		
ł _	161	cobalt same sputter\$3 ((silion adj	USPAT	2003/09/26 14:04
į	101	(oxide or dioxide)) or (aluminum adj	USERI	2003/09/20 14.04
		(oxide or dioxide))) with platinum with		
i		cobalt		
_	51	((silicon adj nitride) or (silion adj	USPAT	2003/09/26 14:04
		(oxide or dioxide)) or (aluminum adj		
		(oxide or dioxide))) with platinum with	1	
		cobalt and sputter\$3		
-	39	(((silicon adj nitride) or (silion adj	USPAT	2003/09/26 14:04
		(oxide or dioxide)) or (aluminum adj		
		(oxide or dioxide))) with platinum with		
1		cobalt and sputter\$3) xor (((silicon adj		
		nitride) or (silion adj (oxide or		
		dioxide)) or (aluminum adj (oxide or		
		dioxide))) with platinum with cobalt same sputter\$3)		į
_	64	1 * ' '	USPAT	2003/09/26 14:32
1	, ·	(silion adj (oxide or dioxide)) or	001111	2003/03/20 14.32
		(aluminum adj (oxide or dioxide))) with		·
		platinum		
-	0	((dual or two or multiple) adj cathode)	USPAT	2003/09/26 14:13
		with ((silicon adj nitride) or (silion adj		
		(oxide or dioxide)) or (aluminum adj		
		(oxide or dioxide))) with platinum		
-	0	' ' ' ' ' ' ' ' ' ' ' ' ' ' ' ' ' ' '	USPAT	2003/09/26 14:14
		with ((silicon adj nitride) or (silion adj (oxide or dioxide)) or (aluminum adj		
		(oxide or dioxide)))		
_	0		USPAT	2003/09/26 14:14
		with ((silicon adj nitride) or (silion adj	552	2000,03,20 11111
}		(oxide or dioxide)) or (aluminum adj		
		(oxide or dioxide)))		
-	14	' '	USPAT	2003/09/26 14:18
		same ((silicon adj nitride) or (silion adj		
		(oxide or dioxide)) or (aluminum adj		
_	1	(oxide or dioxide)))	HCDam	2002/00/06 14 10
		((dual or two or multiple) near2 cathode) and ((silicon adj nitride) or (silion adj	USPAT	2003/09/26 14:18
		(oxide or dioxide)) or (aluminum adj		
		(oxide or dioxide)))with platinum		
-	1		USPAT	2003/09/26 14:18
[		and ((silicon adj nitride) or (silion adj		
		(oxide or dioxide)) or (aluminum adj		
	_	(oxide or dioxide))) with platinum		
-	3		USPAT	2003/09/26 14:21
		and ((silicon adj nitride) or (silion adj		
		(oxide or dioxide)) or (aluminum adj		
_	76	(oxide or dioxide))) same platinum sputter\$3 and ((silicon adj nitride) or	USPAT	2003/09/26 14:21
]	'	(silion adj (oxide or dioxide)) or	OSFAI	2003/03/20 14:21
		(aluminum adj (oxide or dioxide))) near2		
		platinum		
-	11	sputter\$3 same ((silicon adj nitride) or	USPAT	2003/09/26 14:23
		(silion adj (oxide or dioxide)) or	,	
		(aluminum adj (oxide or dioxide))) near2		
	1000	platinum		
-	1930	sputter\$3 with metal near2 (oxide or	USPAT	2003/09/26 14:23
	<u> </u>	nitride)		

- 0 sputter\$3 with metal near2 "with" with USPAT (oxide or nitride) - 0 sputter\$3 with metal near2 "with" near2 USPAT 2003/09/26 (oxide or nitride) - 0 sputter\$3 with metal near2 "with" near2 USPAT 2003/09/26 (oxide or nitride) - 0 sputter\$3 with metal with "with" with USPAT 2003/09/26 (oxide or nitride) - 4469 sputter\$3 with metal with (oxide or USPAT 2003/09/26 nitride) - 2312 sputter\$3 with metal near2 (oxide or nitride) - 0 sputter\$3 with metal near2 (oxide or nitride) sputter\$3 with metal near2 (oxide or nitride) with ((dual or multiple or two))	5 14:23 5 14:24 5 14:28 5 14:28 5 14:28
- 0 sputter\$3 with metal near2 "with" near2	5 14:24 5 14:28 5 14:28 5 14:28
(oxide or nitride)  sputter\$3 with metal near2 "with" near2 (oxide or nitride)  sputter\$3 with metal with "with" with (oxide or nitride)  4469 sputter\$3 with metal with (oxide or nitride)  sputter\$3 with metal with (oxide or nitride)  sputter\$3 with metal near2 (oxide or nitride)  with ((dual or multiple or two)	5 14:24 5 14:28 5 14:28 5 14:28
- 0 sputter\$3 with metal near2 "with" near2	5 14:28 5 14:28 5 14:28
Coxide or nitride)   O sputter\$3 with metal with "with" with   USPAT   2003/09/26     Oxide or nitride)   Oxide or nitride   Oxide or nitri	5 14:28 5 14:28 5 14:28
- 0 sputter\$3 with metal with "with" with (oxide or nitride) - 4469 sputter\$3 with metal with (oxide or nitride) - 2312 sputter\$3 with metal near2 (oxide or nitride) - 0 sputter\$3 with metal near2 (oxide or nitride) - 0 sputter\$3 with metal near2 (oxide or nitride) with ((dual or multiple or two)	5 14:28 5 14:28
(oxide or nitride)  4469 sputter\$3 with metal with (oxide or nitride)  2312 sputter\$3 with metal near2 (oxide or nitride)  5 putter\$3 with metal near2 (oxide or nitride)  6 sputter\$3 with metal near2 (oxide or nitride) with ((dual or multiple or two)	5 14:28 5 14:28
- 4469 sputter\$3 with metal with (oxide or nitride) - 2312 sputter\$3 with metal near2 (oxide or nitride) - 0 sputter\$3 with metal near2 (oxide or nitride) - 0 sputter\$3 with metal near2 (oxide or nitride) with ((dual or multiple or two)	5 14:28
nitride)  2312 sputter\$3 with metal near2 (oxide or nitride)  0 sputter\$3 with metal near2 (oxide or nitride) with ((dual or multiple or two)  USPAT 2003/09/26	5 14:28
- 2312 sputter\$3 with metal near2 (oxide or nitride) - 0 sputter\$3 with metal near2 (oxide or nitride) with ((dual or multiple or two) USPAT 2003/09/26	
nitride)  output  nitride)  sputter\$3 with metal near2 (oxide or nitride) with ((dual or multiple or two)  USPAT 2003/09/26	14:32
nitride) with ((dual or multiple or two)	14:32
nong anthodol	
near2 cathode)	
- 88 dual adj cathode USPAT 2003/09/26	
- 4 (dual adj cathode) and ((silicon adj USPAT 2003/09/26	14:37
nitride) or (silion adj (oxide or	
dioxide)) or (aluminum adj (oxide or	
dioxide))) and platinum - 270 ((silicon adj nitride) or (silion adj USPAT 2003/09/26	14.20
- 270 ((silicon adj nitride) or (silion adj USPAT 2003/09/26 (oxide or dioxide)) or (aluminum adj	14:38
(oxide or dioxide))) near2 platinum	
- 76 ((silicon adj nitride) or (silion adj USPAT 2003/09/26	15.01
(oxide or dioxide)) or (aluminum adj	13.01
(oxide or dioxide))) near2 platinum and	
sputter\$3	
- 1044 cermet with (silion adj (oxide or dioxide USPAT 2003/09/26	14:48
or nitride)) or (aluminum adj (oxide or	
dioxide)) with platinum	ļ
- 223 cermet with (silion adj (oxide or dioxide USPAT 2003/09/26	14:49
or nitride)) or (aluminum adj (oxide or	
dioxide)) near2 platinum	
4 cermet with (silion adj (oxide or dioxide USPAT 2003/09/26	14:50
or nitride)) or (aluminum adj (oxide or dioxide)) near2 platinum same sputter\$3	
- 67 cermet with (silion adj (oxide or dioxide USPAT 2003/09/26	14.51
or nitride)) or (aluminum adj (oxide or	14.51
dioxide)) near2 metal same sputter\$3	
- 88 (silion adj (oxide or dioxide or nitride)) USPAT 2003/09/26	14:51
or (aluminum adj (oxide or dioxide)) near2	
metal same sputter\$3	
- 67 cermet with (silion adj (oxide or dioxide USPAT 2003/09/26	14:52
or nitride)) or (aluminum adj (oxide or	
dioxide)) near2 metal same sputter\$3	
- 1 5227193.pn. USPAT 2003/09/26	
1 5227193.pn. and platinum USPAT 2003/09/26	
- 1 5227193.pn. and prevent\$3 USPAT 2003/09/26 - 1 5227193.pn. and sputtering USPAT 2003/09/26	
- 1 5227193.pn. and sputtering USPAT 2003/09/26 - 1 5846648.pn. USPAT 2003/09/26	
- 1 6183606.pn. USPAT 2003/09/26	
- 1 6242085.pn. USPAT 2003/09/26	
- 3 5846648.pn. or 6183606.pn. or 6242085.pn. USPAT 2003/09/26	
- 1 6242085.pn. USPAT 2003/09/29	
- 0 6242085.pn. and crystalline USPAT 2003/09/29	
- 0 6242085.pn. and crystalliN\$4 USPAT 2003/09/29	
- 0 6242085.pn. and crystalli\$4 USPAT 2003/09/29	09:51
- 1 6242085.pn. and crystal USPAT 2003/09/29	11:11